## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of: Docket No.: 4240-104 Applicants: JUNG, Hee Tae, et al. Conf. No.: 9621 Application No.: 10/805,044 Art Unit: 1639 Date Filed: March 19, 2004 Examiner: Christopher M. Gross Title: METHOD FOR Customer No.: FABRICATING A BIOCHIP

## CERTIFICATE OF EFS FILING

23448

I hereby certify that this document is being filed via EFS in the United States Patent and Trademark Office on January 28,2009.

USING THE HIGH DENSITY CARBON NANOTUBE FILM OR PATTERN

/kelly k. reynolds/

## RESPONSE TO OCTOBER 28, 2008 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/805,044

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir

This responds to the October 28, 2008 Final Office Action. The time for responding to the October 28, 2008 Final Office Action without extension was set at three months, or January 28, 2009. This Response is therefore timely.

Please amend the claims of the above-identified patent application as set out in Section I, Amendments to the Claims, beginning on page 3 hereof.

DO NOT ENTER: /Christopher Gross/ (03/19/2009)